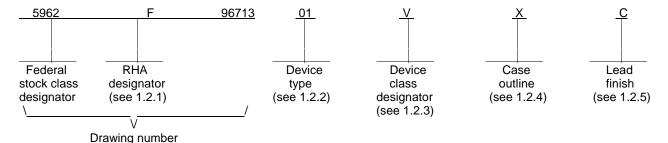
									REVISI	ONS										
LTR						DESCF	RIPTIO						D/	ATE (Y	R-MO-I	DA)	APPROVED			
A	Char	age in	accord	lanco u									97-10-22			Monica L. Poolking				
				lance w													Monica L. Poelking			
В	Char	nges in	accord	lance w	ith NO	R 5962	?-R012-	-99.						98-1	11-03		Mon	ica L. P	oelking	g
С	Upda chan	ate boile ges thr	erplate oughou	to MIL- ut tmh	PRF-3	8535 a	nd upd	ated ap	opendix	k A. Ed	itorial			00-0	06-26		Mon	ica L. P	oelking	g
DEV						I				1	I	1		1		1			1	1
REV SHEET																				
REV	С	С	С	С	С	С	С	С	С	С										
SHEET	15	16	17	18	19	20	21	22	23	24										
REV STATUS	1 .5	1 .0		REV			C	C	C C	C	С	С	С	С	С	С	С	С	С	С
OF SHEETS				SHE			1	2	3	4	5	6	7	8	9	10	11	12	13	14
PMIC N/A				PRE	PARED	BY	1	1	1		1	1	1	1	1	1	1	1	1	1
				Than	h V. N	guyen													_	
OT A	NDAF	) D		CUE	CKED	DV				4		DEFE				NTER HIO 4		JMBU:	S	
MICRO					CKED								501	-01110	JJ, U	4	J_ 10			
	AWIN			inan	h V. N	yuyen														
				APP	ROVE	D BY														
THIS DRAWIN FOR U			BLE	Moni	ca L. P	oelking	)												בוום	
DEPAI	RTMEN	TS	_	<u> </u>								NED : /ITH :								
AND AGEN DEPARTMEN				DRA	WING.	APPR(	DVAL D	DATE										J.VII	<i>.</i> ۱۰ ا	
			95-01-22				515, 1116			MONOLITHIC SILICON				•						
AMSC N/A REVISION LEVEL				SIZE CAGE CODE																
AM	SC N/A			REV	ISION I	LEVEL				SI	ZE	CA	GE CC	DE			5060	0674	2	
АМ	SC N/A			REV	ISION I		C				ZE A		GE CC			;	5962·	9671	3	

- 1. SCOPE
- 1.1 <u>Scope</u>. This drawing documents two product assurance class levels consisting of high reliability (device classes Q and M) and space application (device class V). A choice of case outlines and lead finishes are available and are reflected in the Part or Identifying Number (PIN). When available, a choice of Radiation Hardness Assurance (RHA) levels are reflected in the PIN
  - 1.2 PIN. The PIN is as shown in the following example:



- 1.2.1 RHA designator. Device classes Q and V RHA marked devices meet the MIL-PRF-38535 specified RHA levels and are marked with the appropriate RHA designator. Device class M RHA marked devices meet the MIL-PRF-38535, appendix A specified RHA levels and are marked with the appropriate RHA designator. A dash (-) indicates a non-RHA device.
  - 1.2.2 <u>Device type(s)</u>. The device type(s) identify the circuit function as follows:

Device type	Generic number	Circuit function
01	ACTS74	Radiation hardened SOS, advanced CMOS, dual D flip-flop with set and reset, TTL compatible inputs
02	ACTS74-02 <u>1</u> /	Radiation hardened SOS, advanced CMOS, dual D flip-flop with set and reset, TTL compatible inputs

1.2.3 <u>Device class designator</u>. The device class designator is a single letter identifying the product assurance level as follows:

<u>Device class</u>	Device requirements documentation
М	Vendor self-certification to the requirements for MIL-STD-883 compliant, non-JAN class level B microcircuits in accordance with MIL-PRF-38535, appendix A
Q or V	Certification and qualification to MIL-PRF-38535

1.2.4 Case outline(s). The case outline(s) are as designated in MIL-STD-1835 and as follows:

Outline letter	Descriptive designator	<u>Terminals</u>	Package style
С	CDIP2-T14	14	dual-in-line package
Χ	CDFP3-F14	14	flat package

- 1.2.5 <u>Lead finish</u>. The lead finish is as specified in MIL-PRF-38535 for device classes Q and V or MIL-PRF-38535, appendix A for device class M.
- 1/ Device type -02 is the same as device type -01 except that the device type -02 products are manufactured at an overseas wafer foundry. Device type -02 is used to positively identify, by marketing part number and by brand of the actual device, material that is supplied by an overseas foundry.

STANDARD MICROCIRCUIT DRAWING	SIZE <b>A</b>		5962-96713
DEFENSE SUPPLY CENTER COLUMBUS COLUMBUS, OHIO 43216-5000		REVISION LEVEL C	SHEET 2

1.3 Absolute maximum ratings. 1/2/3/	
Supply voltage range (V <sub>CC</sub> )	-0.5 V dc to +7.0 V dc
DC input voltage range (V <sub>IN</sub> )	
DC output voltage range (V <sub>IN</sub> )	
DC input current, any one input (I <sub>IN</sub> )	
DC output current, any one output (I <sub>OUT</sub> )	
Storage temperature range (T <sub>STG</sub> )	65°C to +150°C
Lead temperature (soldering, 10 seconds)	+265°C
Thermal resistance, junction-to-case ( $\theta_{JC}$ ):	
Case outline C	24°C/W
Case outline X	
Thermal resistance, junction-to-ambient (θ <sub>JA</sub> ):	7400/14/
Case outline C	
Case outline X	
Junction temperature (T <sub>J</sub> )	+175°C
Maximum package power dissipation at $T_A = +125$ °C ( $P_D$ ): $4/$	
Case outline C	0.68 W
Case outline X	0.43 W
1.4 Recommended operating conditions. 2/3/	
	14 E V do to 1 E E V do
Supply voltage range (V <sub>CC</sub> )	
Input voltage range (V <sub>IN</sub> )	
Output voltage range (V <sub>OUT</sub> )	
Maximum low level input voltage (V <sub>IL</sub> )	
Minimum high level input voltage (V <sub>IH</sub> )	V <sub>CC</sub> /2
Case operating temperature range (T <sub>C</sub> )	55°C to +125°C
Maximum input rise and fall time at $V_{CC} = 4.5 \text{ V}$ (t <sub>r</sub> , t <sub>f</sub> )	
Radiation features:	
Total dose	> 3 x 10 <sup>5</sup> Pade (Si)
Single event phenomenon (SEP) effective	400 May///am 2/may/ 5/
linear energy threshold (LET) no upsets (see 4.4.4.4)	> 100 MeV/(cm /mg) <u>5/</u>
Dose rate upset (20 ns pulse)	
Latch-up	None <u>5/</u>
Dose rate survivability	> 1 x 10 <sup>12</sup> Rads (Si)/s <u>5</u> /
2. APPLICABLE DOCUMENTS	
2.1 Government specification, standards, and handbooks. The followin	g specification, standards, and handbooks form a
part of this drawing to the extent specified herein. Unless otherwise speci-	fied, the issues of these documents are those listed in
the issue of the Department of Defense Index of Specifications and Standa	ards (DoDISS) and supplement thereto, cited in the
solicitation.	ardo (Bobileo) and cappionion and one of cited in and
Solicitation.	
CDECIFICATION	
SPECIFICATION	
DEDARTMENT OF DEFENOE	
DEPARTMENT OF DEFENSE	
MIL-PRF-38535 - Integrated Circum its, Manufacturing, General S	Specification for.
1/ Stresses above the absolute maximum rating may cause permanent of	damage to the device. Extended operation at the
maximum levels may degrade performance and affect reliability.	zamago to ino domosi =zaonaca operanen at ino
2/ Unless otherwise specified, all voltages are referenced to GND.	
	anacified \/ range and case temperature range of
The limits for the parameters specified herein shall apply over the full	specified v <sub>CC</sub> range and case temperature range or -
55°C to +125°C unless otherwise noted.	
4/ If device power exceeds package dissipation capability, provide heat	sinking or derate linearly (the derating is
based on $\theta_{JA}$ ) at the following rate:	
Case C	
Case X	
5/ Guaranteed by design or process but not tested.	

STANDARD MICROCIRCUIT DRAWING	SIZE <b>A</b>		5962-96713
DEFENSE SUPPLY CENTER COLUMBUS COLUMBUS, OHIO 43216-5000		REVISION LEVEL C	SHEET 3

## STANDARDS

## **DEPARTMENT OF DEFENSE**

MIL-STD-883 - Test Method Standard Microcircuits.

MIL-STD-973 - Configuration Management.

MIL-STD-1835 - Interface Standard For Microcircuit Case Outlines.

## **HANDBOOKS**

## DEPARTMENT OF DEFENSE

MIL-HDBK-103 - List of Standard Microcircuit Drawings (SMD's).

MIL-HDBK-780 - Standard Microcircuit Drawings.

(Unless otherwise indicated, copies of the specification, standards, and handbooks are available from the Standardization Document Order Desk, 700 Robbins Avenue, Building 4D, Philadelphia, PA 19111-5094.)

2.2 <u>Order of precedence</u>. In the event of a conflict between the text of this drawing and the references cited herein, the text of this drawing takes precedence. Nothing in this document, however, supersedes applicable laws and regulations unless a specific exemption has been obtained.

## 3. REQUIREMENTS

- 3.1 <u>Item requirements</u>. The individual item requirements for device classes Q and V shall be in accordance with MIL-PRF-38535 and as specified herein or as modified in the device manufacturer's Quality Management (QM) plan. The modification in the QM plan shall not affect the form, fit, or function as described herein. The individual item requirements for device class M shall be in accordance with MIL-PRF-38535, appendix A for non-JAN class level B devices and as specified herein.
  - 3.1.1 Microcircuit die. For the requirements for microcircuit die, see appendix A to this document.
- 3.2 <u>Design, construction, and physical dimensions</u>. The design, construction, and physical dimensions shall be as specified in MIL-PRF-38535 and herein for device classes Q and V or MIL-PRF-38535, appendix A and herein for device class M.
  - 3.2.1 Case outlines. The case outlines shall be in accordance with 1.2.4 herein.
  - 3.2.2 Terminal connections. The terminal connections shall be as specified on figure 1.
  - 3.2.3 Truth table. The truth table shall be as specified on figure 2.
  - 3.2.4 Logic diagram. The logic diagram shall be as specified on figure 3.
  - 3.2.5 Switching waveform and test circuit. The switching waveforms and test circuits shall be as specified on figure 4.
  - 3.2.6 Radiation exposure circuit. The radiation test connections shall be as specified in table III herein.
- 3.3 <u>Electrical performance characteristics and postirradiation parameter limits</u>. Unless otherwise specified herein, the electrical performance characteristics and postirradiation parameter limits are as specified in table I and shall apply over the full case operating temperature range.
- 3.4 <u>Electrical test requirements</u>. The electrical test requirements shall be the subgroups specified in table II. The electrical tests for each subgroup are defined in table I.
- 3.5 <u>Marking</u>. The part shall be marked with the PIN listed in 1.2 herein. In addition, the manufacturer's PIN may also be marked as listed in MIL-HDBK-103. For packages where marking of the entire SMD PIN number is not feasible due to space limitations, the manufacturer has the option of not marking the "5962-" on the device. For RHA product using this option, the RHA designator shall still be marked. Marking for device classes Q and V shall be in accordance with MIL-PRF-38535. Marking for device class M shall be in accordance with MIL-PRF-38535, appendix A.
- 3.5.1 <u>Certification/compliance mark</u>. The certification mark for device classes Q and V shall be a "QML" or "Q" as required in MIL-PRF-38535. The compliance mark for device class M shall be a "C" as required in MIL-PRF-38535, appendix A.

STANDARD MICROCIRCUIT DRAWING	SIZE <b>A</b>		5962-96713
DEFENSE SUPPLY CENTER COLUMBUS COLUMBUS, OHIO 43216-5000		REVISION LEVEL C	SHEET 4

- 3.6 <u>Certificate of compliance</u>. For device classes Q and V, a certificate of compliance shall be required from a QML-38535 listed manufacturer in order to supply to the requirements of this drawing (see 6.6.1 herein). For device class M, a certificate of compliance shall be required from a manufacturer in order to be listed as an approved source of supply in MIL-HDBK-103 (see 6.6.2 herein). The certificate of compliance submitted to DSCC-VA prior to listing as an approved source of supply for this drawing shall affirm that the manufacturer's product meets, for device classes Q and V, the requirements of MIL-PRF-38535 and herein or for device class M, the requirements of MIL-PRF-38535, appendix A and herein.
- 3.7 <u>Certificate of conformance</u>. A certificate of conformance as required for device classes Q and V in MIL-PRF-38535 or for device class M in MIL-PRF-38535, appendix A shall be provided with each lot of microcircuits delivered to this drawing.
- 3.8 <u>Notification of change for device class M.</u> For device class M, notification to DSCC-VA of change of product (see 6.2 herein) involving devices acquired to this drawing is required for any change as defined in MIL-STD-973.
- 3.9 <u>Verification and review for device class M.</u> For device class M, DSCC, DSCC's agent, and the acquiring activity retain the option to review the manufacturer's facility and applicable required documentation. Offshore documentation shall be made available onshore at the option of the reviewer.
- 3.10 <u>Microcircuit group assignment for device class M.</u> Device class M devices covered by this drawing shall be in microcircuit group number 39 (see MIL-PRF-38535, appendix A).

## 4. QUALITY ASSURANCE PROVISIONS

- 4.1 <u>Sampling and inspection</u>. For device classes Q and V, sampling and inspection procedures shall be in accordance with MIL-PRF-38535 or as modified in the device manufacturer's Quality Management (QM) plan. The modification in the QM plan shall not affect the form, fit, or function as described herein. For device class M, sampling and inspection procedures shall be in accordance with MIL-PRF-38535, appendix A.
- 4.2 <u>Screening</u>. For device classes Q and V, screening shall be in accordance with MIL-PRF-38535, and shall be conducted on all devices prior to qualification and technology conformance inspection. For device class M, screening shall be in accordance with method 5004 of MIL-STD-883, and shall be conducted on all devices prior to quality conformance inspection.
  - 4.2.1 Additional criteria for device class M.
    - a. Burn-in test, method 1015 of MIL-STD-883.
      - (1) Test condition A, B, C or D. The test circuit shall be maintained by the manufacturer under document revision level control and shall be made available to the preparing or acquiring activity upon request. The test circuit shall specify the inputs, outputs, biases, and power dissipation, as applicable, in accordance with the intent specified in test method 1015.
      - (2)  $T_A = +125^{\circ}C$ , minimum.
    - b. Interim and final electrical test parameters shall be as specified in table IIA herein.
  - 4.2.2 Additional criteria for device classes Q and V.
    - a. The burn-in test duration, test condition and test temperature, or approved alternatives shall be as specified in the device manufacturer's QM plan in accordance with MIL-PRF-38535. The burn-in test circuit shall be maintained under document revision level control of the device manufacturer's Technology Review Board (TRB) in accordance with MIL-PRF-38535 and shall be made available to the acquiring or preparing activity upon request. The test circuit shall specify the inputs, outputs, biases, and power dissipation, as applicable, in accordance with the intent specified in test method 1015 of MIL-STD-883.
    - b. Interim and final electrical test parameters shall be as specified in table IIA herein.
    - c. Additional screening for device class V beyond the requirements of device class Q shall be as specified in MIL-PRF-38535, appendix B.
- 4.3 <u>Qualification inspection for device classes Q and V</u>. Qualification inspection for device classes Q and V shall be in accordance with MIL-PRF-38535. Inspections to be performed shall be those specified in MIL-PRF-38535 and herein for groups A, B, C, D, and E inspections (see 4.4.1 through 4.4.4).

STANDARD MICROCIRCUIT DRAWING	SIZE <b>A</b>		5962-96713
DEFENSE SUPPLY CENTER COLUMBUS COLUMBUS, OHIO 43216-5000		REVISION LEVEL C	SHEET 5

	TABLE I. <u>E</u>	Electrical performance	characteris	tics.				
Symbol	-55°C ≤ T <sub>C</sub>	; ≤ +125°C	Device type	V <sub>cc</sub>	Group A subgroups	Limi Min	ts <u>2</u> / Max	Unit
V <sub>он</sub>	output under test	-	All	4.5 V	1, 2, 3	4.40		V
		M, D, L, R, F <u>3</u> /	All		1	4.40		
	output under test		All	5.5 V	1, 2, 3	5.40		
		M, D, L, R, F <u>3</u> /	All		1	5.40		
V <sub>OL</sub>	output under test	-	All	4.5 V	1, 2, 3		0.1	V
		M, D, L, R, F <u>3</u> /	All		1		0.1	
	output under test	-	All	5.5 V	1, 2, 3		0.1	
		M, D, L, R, F <u>3</u> /	All		1		0.1	
I <sub>IH</sub>	For input under test, ' For all other inputs	V <sub>IN</sub> = 5.5 V	All	5.5 V	1		+0.5	μА
	$V_{IN} = V_{CC}$ or $\dot{G}ND$	MDIBE	ΔII		2, 3		+1.0	
		M, D, L, R, F <u>3</u> /	All		'		+1.0	
I <sub>IL</sub>	For all other inputs	$V_{IN} = GND$	All	5.5 V	1		-0.5	μΑ
	$V_{IN} = V_{CC}$ or GND	M, D, L, R, F	All		2, 3		-1.0 -1.0	
	Vol	Symbol  Test conditions of the roll of the result of the roll o	$\begin{tabular}{ c c c c c } \hline Symbol & Test conditions $1/\\ -55^{\circ}C \le T_{C} \le +125^{\circ}C \\ unless otherwise specified \\ \hline $V_{OH}$ & For all inputs affecting output under test $V_{IN} = 2.25 \ V \ or 0.80 \ V$ For all other inputs $V_{IN} = V_{CC} \ or GND $I_{OH} = -50 \ \mu A$ \\ \hline & M, D, L, R, F$ \\ \hline \hline $For \ all inputs \ affecting output under test $V_{IN} = 2.75 \ V \ or 0.80 \ V$ For all other inputs $V_{IN} = V_{CC} \ or GND $I_{OH} = -50 \ \mu A$ \\ \hline & M, D, L, R, F$ \\ \hline \hline $V_{OL}$ & For all inputs affecting output under test $V_{IN} = 2.25 \ V \ or 0.80 \ V$ For all other inputs $V_{IN} = V_{CC} \ or GND $I_{OL} = 50 \ \mu A$ \\ \hline & M, D, L, R, F$ \\ \hline \hline $M, D, L, R, F$ \\ \hline $M, D, L, R, F$ \\ \hline \hline $M, D, L, R, F$ \\ \hline $M, D, L, R, F$ \\ \hline \hline \ $M, D, L, R, F$ \\ \hline \hline \ $M, D, L, R, F$ \\ \hline \hline \ $M, D, L, R, F$ \\ \hline \ \ \ \end{tabular}$	$\begin{tabular}{ c c c c c c c c c c c c c c c c c c c$	$V_{OH} = \frac{-55^{\circ}\text{C} \cdot \text{T}_{\text{C}} \leq +125^{\circ}\text{C}}{\text{unless otherwise specified}} \qquad \text{All} \qquad 4.5 \text{ V}$ $V_{OH} = \frac{1}{2} \sum_{\text{Output under test}} V_{\text{IN}} = 2.25 \text{ V or } 0.80 \text{ V}$ $For all inputs affecting} \text{output under test} V_{\text{IN}} = -50  \mu\text{A}$ $V_{IN} = V_{\text{CC}} \text{ or GND}$ $I_{OH} = -50  \mu\text{A}$ $V_{OL} = \frac{1}{2} \sum_{\text{OUTPUT}} $	$ \begin{array}{c ccccccccccccccccccccccccccccccccccc$	$ \begin{array}{c ccccccccccccccccccccccccccccccccccc$	$ \begin{array}{c ccccccccccccccccccccccccccccccccccc$

See footnotes at end of table.

STANDARD MICROCIRCUIT DRAWING	SIZE <b>A</b>		5962-96713
DEFENSE SUPPLY CENTER COLUMBUS COLUMBUS, OHIO 43216-5000		REVISION LEVEL C	SHEET 6

		TABLE I. Electric	al performance chara	cteristics - 0	Continued				
Test	t Symbol		Test conditions $\underline{1}/$ -55°C $\leq$ T <sub>C</sub> $\leq$ +125°C		$V_{CC}$	Group A subgroups	Limi	ts <u>2</u> /	Unit
		unless otherv		type		oubgroups	Min	Max	
Output current high (Source)	I <sub>OH</sub> <u>4</u> /	For all inputs affecting under test, V <sub>IN</sub> = 4.5		All	4.5 V	1	-12.0		mA
,		For all other inputs $V_{IN} = V_{CC} \text{ or GND}$				2, 3	-8.0		
		V <sub>OUT</sub> = 4.1 V	M, D, L, R, F <u>3</u> /	All		1	-8.0		
Output current low (Sink)	I <sub>OL</sub> <u>4</u> /	For all inputs affecting under test, V <sub>IN</sub> = 4.5		All	4.5 V	1	12.0		mA
		For all other inputs $V_{IN} = V_{CC}$ or GND				2, 3	8.0		
		V <sub>OUT</sub> = 0.4 V	M, D, L, R, F <u>3</u> /	All		1	8.0		
Quiescent supply current delta, TTL input levels	ΔI <sub>CC</sub> <u>5</u> /	For inputs under test $V_{IN} = V_{CC} - 2.1 \text{ V}$ For all other inputs $V_{IN} = V_{CC}$ or GND		All	5.5 V	1, 2, 3		1.0	mA
	M, D, L, R, F All 3/		1		1.0				
Quiescent supply current	Icc	$V_{IN} = V_{CC}$ or GND		All	5.5 V	1		10.0	μА
Current						2, 3		200.0	
			M, D, L, R, F <u>3</u> /	All		1		200.0	
Input capacitance	C <sub>IN</sub>	$V_{IH} = 5.0 \text{ V}, V_{IL} = 0.0 \text{ V}$		All	5.0 V	4		10	pF
Power dissipation	C <sub>PD</sub>	f = 1 MHz, see 4.4.1c	;	All	5.0 V	4		65	pF
capacitance	<u>6</u> /					5, 6		75	
Functional test	<u>7</u> /	$V_{IH} = 2.25 \text{ V}, V_{IL} = 0.8$	0 V	All	4.5 V	7, 8	L	Н	
		See 4.4.1b	M, D, L, R, F <u>3</u> /	All		7	L	Н	
Propagation delay	t <sub>PLH1</sub> 8/	$C_L = 50 \text{ pF}$ $R_L = 500\Omega$		All	4.5 V	9	1.0	15.0	ns
time, nCP to nQ or nQ	<u>o</u> /	See figure 4				10, 11	1.0	18.0	
			M, D, L, R, F <u>3</u> /	All		9	1.0	18.0	
	t <sub>PHL1</sub>	C <sub>L</sub> = 50 pF		All	4.5 V	9	1.0	20.0	
	<u>8</u> /	$R_L = 500\Omega$ See figure 4				10, 11	1.0	20.0	
			M, D, L, R, F <u>3</u> /	All		9	1.0	20.0	

See footnotes at end of table.

STANDARD MICROCIRCUIT DRAWING	SIZE <b>A</b>		5962-96713
DEFENSE SUPPLY CENTER COLUMBUS COLUMBUS, OHIO 43216-5000		REVISION LEVEL C	SHEET 7

Test	Symbol		nditions 1/	Device	$V_{CC}$	Group A	Limi	ts <u>2</u> /	Uni	
			c ≤ +125°C type wise specified				subgroups	Min	Max	
Propagation delay time, nS to nQ	t <sub>PLH2</sub>	C <sub>L</sub> = 50 pF		All	4.5 V	9	1.0	12.0	ns	
	<u>8</u> /	$R_L = 500\Omega$ See figure 4				10, 11	1.0	13.0		
			M, D, L, R, F <u>3</u> /	All		9	1.0	13.0		
Propagation delay	t <sub>PHL2</sub>	C <sub>L</sub> = 50 pF		All	4.5 V	9	1.0	16.0	ns	
time, nS to nQ	<u>8</u> /	$R_L = 500\Omega$ See figure 4				10, 11	1.0	17.0		
			M, D, L, R, F <u>3</u> /	All		9	1.0	17.0		
Propagation delay	t <sub>PLH3</sub>	C <sub>L</sub> = 50 pF	1	All	4.5 V	9	1.0	12.0	n	
time, nR to nQ	<u>8</u> /	$R_L = 500\Omega$ See figure 4					10, 11	1.0	13.0	
			M, D, L, R, F <u>3</u> /	All		9	1.0	13.0		
Propagation delay	t <sub>PHL3</sub>	C <sub>L</sub> = 50 pF	-	All	4.5 V	9	1.0	16.0	n	
time, nR to nQ	<u>8</u> /	$R_L = 500\Omega$ See figure 4				10, 11	1.0	17.0		
			M, D, L, R, F <u>3</u> /	All		9	1.0	17.0		
Output transition	t <sub>THL</sub> ,	C <sub>L</sub> = 50 pF	1	All	4.5 V	9	1.0	11.0	n	
time	t <sub>TLH</sub> <u>8</u> /	$R_L = 500\Omega$ See figure 4				10, 11	1.0	12.0		
			M, D, L, R, F <u>3</u> /	All		9	1.0	12.0		
Maximum clock	f <sub>MAX</sub>	C <sub>L</sub> = 50 pF	•	All	4.5 V	9	79.0		MI	
frequency	<u>9</u> /	$R_L = 500\Omega$ See figure 4				10, 11	76.0			
Setup time, high or low, nD to nCP	t <sub>s</sub>			All	4.5 V	9	4.3		n	
iow, fib to fici	<u>s</u> /					10, 11	4.9			
Hold time, high or low, nD to nCP	t <sub>h</sub> <u>9</u> /			All	4.5 V	9	2.0		n	
	<u> </u>					10, 11	2.0			
nR or nS pulse width, low	t <sub>w1</sub> <u>9</u> /			All	4.5 V	9	5.5		n	
	<del> </del>					10, 11	6.3			
nCP pulse width, high or low	t <sub>w2</sub> <u>9</u> /			All	4.5 V	9	5.5		n	
						10, 11	6.3			
Recovery time, nR	t <sub>REC</sub>			All	4.5 V	9	3.7		n	

See footnotes on next sheet.

STANDARD MICROCIRCUIT DRAWING	SIZE <b>A</b>		5962-96713
DEFENSE SUPPLY CENTER COLUMBUS COLUMBUS, OHIO 43216-5000		REVISION LEVEL C	SHEET 8

## TABLE I. Electrical performance characteristics - Continued.

- 1/ Each input/output, as applicable, shall be tested at the specified temperature, for the specified limits, to the tests in table I herein. Output terminals not designated shall be high level logic, low level logic, or open, except for the I<sub>CC</sub> and ΔI<sub>CC</sub> tests, the output terminals shall be open. When performing the I<sub>CC</sub> and ΔI<sub>CC</sub> tests, the current meter shall be placed in the circuit such that all current flows through the meter.
- 2/ For negative and positive voltage and current values, the sign designates the potential difference in reference to GND and the direction of current flow respectively; and the absolute value of the magnitude, not the sign, is relative to the minimum and maximum limits, as applicable, listed herein.
- Devices supplied to this drawing meet all levels M, D, L, R, and F of irradiation. However, this device is only tested at the "F" level. Pre and post irradiation values are identical unless otherwise specified in table I. When performing post irradiation electrical measurements for any RHA level, T<sub>A</sub> = +25°C.
- 4/ Force/Measure functions may be interchanged.
- 5/ This test may be performed either one input at a time (preferred method) or with all input pins simultaneously at V<sub>IN</sub> = V<sub>CC</sub> 2.1 V (alternate method). Classes Q and V shall use the preferred method. When the test is performed using the alternate test method, the maximum limit is equal to the number of inputs at a high TTL input level times 1.0 mA; and the preferred method and limits are guaranteed. For the preferred method, a minimum of one input shall be tested. All other inputs shall be guaranteed, if not tested, to the limits specified in table I herein.
- 6/ Power dissipation capacitance ( $C_{PD}$ ) determines both the power consumption ( $P_D$ ) and current consumption ( $I_S$ ). Where  $P_D = (C_{PD} + C_L) (V_{CC} \times V_{CC}) f + (I_{CC} \times V_{CC}) + (n \times d \times \Delta I_{CC} \times V_{CC})$   $I_S = (C_{PD} + C_L) V_{CC} f + I_{CC} + (n \times d \times \Delta I_{CC})$

f is the frequency of the input signal, n is the number of device inputs at TTL levels; and d is the duty cycle of the input signal.

- 7/ The test vectors used to verify the truth table shall, at a minimum, test all functions of each input and output. All possible input to output logic patterns per function shall be guaranteed, if not tested, to the truth table in figure 2 herein. For  $V_{OUT}$  measurements,  $L \le 0.5$  V and  $H \ge 4.0$  V.
- 8/ AC limits at V<sub>CC</sub> = 5.5 V are equal to the limits at V<sub>CC</sub> = 4.5 V. For propagation delay tests, all paths must be tested.
- 9/ This parameter is guaranteed but not tested. This parameter is characterized upon initial design or process changes which affect this characteristic.

STANDARD					
MICROCIRCUIT DRAWING					

SIZE <b>A</b>		5962-96713
	REVISION LEVEL C	SHEET 9

Device type	All			
Case outlines		C and X		
Terminal number	Terminal symbol	Terminal number	Terminal symbol	
1	1R	8	2Q	
2	1D	9	2Q	
3	1CP	10	28	
4	18	11	2CP	
5	1Q	12	2D	
6	1Q	13	2R	
7	GND	14	V <sub>cc</sub>	

FIGURE 1. <u>Terminal connections</u>.

Inputs			Out	puts	
nS	nR	nCP	nD	nQ	nQ
L	Н	Х	Х	Н	L
Н	L	Х	Х	L	Н
L	L	Х	Х	H <u>1</u> /	H <u>1</u> /
Н	Н	<b>↑</b>	Н	Н	L
Н	Н	<b>↑</b>	L	L	Н
Н	Н	L	Х	Q0	Q0

 $<sup>\</sup>underline{1}$ / This configuration is non-stable, that is, it will not persist when set and reset inputs return to their inactive (high) level.

H = High voltage level L = Low voltage level X = Don't care

FIGURE 2. Truth table.

STANDARD MICROCIRCUIT DRAWING	SIZE <b>A</b>		5962-96713
DEFENSE SUPPLY CENTER COLUMBUS COLUMBUS, OHIO 43216-5000		REVISION LEVEL C	SHEET 10

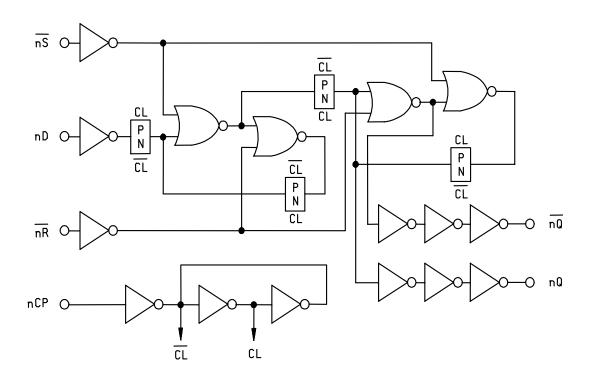


FIGURE 3. Logic diagram.

STANDARD MICROCIRCUIT DRAWING	SIZE <b>A</b>		5962-96713
DEFENSE SUPPLY CENTER COLUMBUS		REVISION LEVEL	SHEET
COLUMBUS, OHIO 43216-5000		C	11

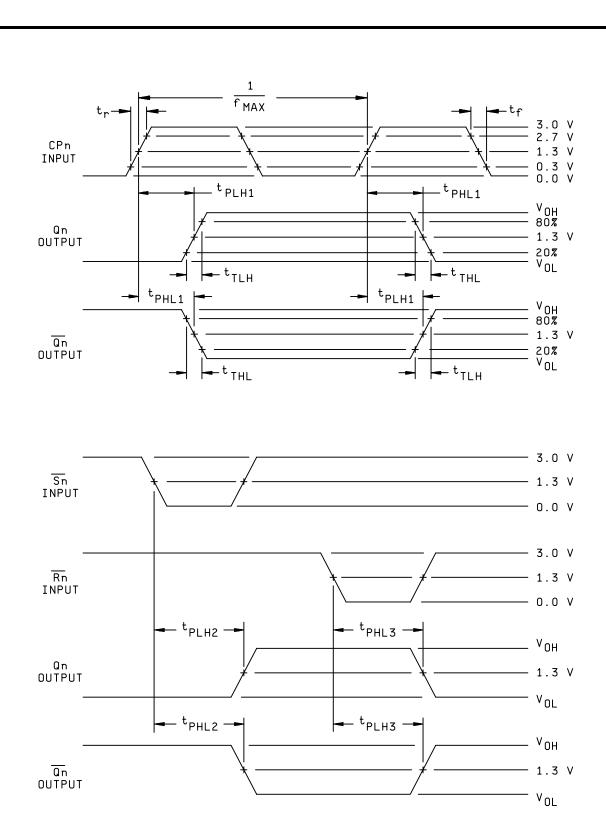
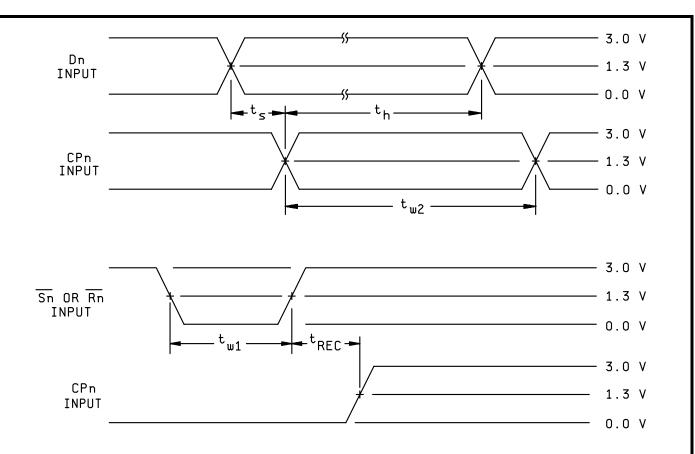
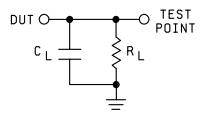


FIGURE 4. Switching waveforms and test circuit.

STANDARD MICROCIRCUIT DRAWING	SIZE <b>A</b>		5962-96713
DEFENSE SUPPLY CENTER COLUMBUS COLUMBUS, OHIO 43216-5000		REVISION LEVEL C	SHEET 12





## NOTES:

- 1.  $C_L = 50 \text{ pF minimum or equivalent (includes test jig and probe capacitance)}$ .
- 2.  $R_L = 500\Omega$  or equivalent.
- 3. Input signal from pulse generator:  $V_{IN} = 0.0 \text{ V}$  to 3.0 V; PRR  $\leq$  10 MHz;  $t_r \leq$  3.0 ns;  $t_r \leq$  3.0 ns;  $t_r \leq$  3.0 ns;  $t_r \leq$  4.0 ns;  $t_r \leq$  5.0 ns;  $t_r \leq$  5.0 ns;  $t_r \leq$  5.0 ns;  $t_r \leq$  5.0 ns;  $t_r \leq$  6.1 ns  $t_r \leq$  6.1 ns t

FIGURE 4. Switching waveforms and test circuit - Continued.

STANDARD MICROCIRCUIT DRAWING	SIZE <b>A</b>		5962-96713
DEFENSE SUPPLY CENTER COLUMBUS COLUMBUS, OHIO 43216-5000		REVISION LEVEL C	SHEET 13

4.4 <u>Conformance inspection</u>. Technology conformance inspection for classes Q and V shall be in accordance with MIL-PRF-38535 including groups A, B, C, D, and E inspections and as specified herein except where option 2 of MIL-PRF-38535 permits alternate in-line control testing. Quality conformance inspection for device class M shall be in accordance with MIL-PRF-38535, appendix A and as specified herein. Inspections to be performed for device class M shall be those specified in method 5005 of MIL-STD-883 and herein for groups A, B, C, D, and E inspections (see 4.4.1 through 4.4.4).

#### 4.4.1 Group A inspection.

- a. Tests shall be as specified in table IIA herein.
- b. For device class M, subgroups 7 and 8 tests shall be sufficient to verify the truth table. For device classes Q and V, subgroups 7 and 8 shall include verifying the functionality of the device; these tests shall have been fault graded in accordance with MIL-STD-883, test method 5012 (see 1.5 herein).
- c. Subgroup 4 (C<sub>IN</sub> and C<sub>PD</sub> measurement) shall be measured only for the initial qualification and after process or design changes which may affect capacitance. C<sub>IN</sub> shall be measured between the designated terminal and GND at a frequency of 1 MHz. For C<sub>IN</sub> and C<sub>PD</sub> the tests shall be sufficient to validate the limits defined in table I herein.

TABLE IIA. Electrical test requirements.

Test requirements	Subgroups (in accordance with MIL-STD-883, method 5005, table I)	Subgroups (in accordance with MIL-PRF-38535, table III)	
	Device class M	Device class Q	Device class V
Interim electrical parameters (see 4.2)	1, 7, 9	1, 7, 9	1, 7, 9
Final electrical parameters (see 4.2)	1, 2, 3, 7, 8, 9, 10, 11 <u>1</u> /	1, 2, 3, 7, 8, 9, 10, 11 <u>1</u> /	1, 2, 3, 7, 8, 9, 10, 11 <u>2</u> / <u>3</u> /
Group A test requirements (see 4.4)	1, 2, 3, 4, 5, 6, 7, 8, 9, 10, 11	1, 2, 3, 4, 5, 6, 7, 8, 9, 10, 11	1, 2, 3, 4, 7, 8, 9, 10, 11
Group C end-point electrical parameters (see 4.4)	1, 2, 3, 7, 8, 9, 10, 11	1, 2, 3, 7, 8, 9, 10, 11	1, 2, 3, 7, 8, 9, 10, 11 <u>3</u> /
Group D end-point electrical parameters (see 4.4)	1, 7, 9	1, 7, 9	1, 7, 9
Group E end-point electrical parameters (see 4.4)	1, 7, 9	1, 7, 9	1, 7, 9

<sup>1/</sup> PDA applies to subgroup 1 and 7.

TABLE IIB. Burn-in and operating life test, Delta parameters (+25°C).

Parameters <u>1</u> /	Delta limits
Icc	±2 μA
l <sub>oL</sub> /l <sub>oн</sub>	±15%

<sup>1/</sup> These parameters shall be recorded before and after the required burn-in and life test to determine delta limits.

4.4.2 Group C inspection. The group C inspection end-point electrical parameters shall be as specified in table II herein.

STANDARD MICROCIRCUIT DRAWING	SIZE <b>A</b>		5962-96713
DEFENSE SUPPLY CENTER COLUMBUS COLUMBUS, OHIO 43216-5000		REVISION LEVEL C	SHEET 14

<sup>2/</sup> PDA applies to subgroups 1, 7, 9 and deltas.

<sup>3/</sup> Delta limits as specified in table IIB shall be required where specified, and the delta limits shall be completed with reference to the zero hour electrical parameters (see Table I)

- 4.4.2.1 Additional criteria for device class M. Steady-state life test conditions, method 1005 of MIL-STD-883:
  - a. Test condition A, B, C or D. The test circuit shall be maintained by the manufacturer under document revision level control and shall be made available to the preparing or acquiring activity upon request. The test circuit shall specify the inputs, outputs, biases, and power dissipation, as applicable, in accordance with the intent specified in test method 1005 of MIL-STD-883.
  - b.  $T_A = +125^{\circ}C$ , minimum.
  - c. Test duration: 1,000 hours, except as permitted by method 1005 of MIL-STD-883.
- 4.4.2.2 Additional criteria for device classes Q and V. The steady-state life test duration, test condition and test temperature, or approved alternatives shall be as specified in the device manufacturer's QM plan in accordance with MIL-PRF-38535. The test circuit shall be maintained under document revision level control by the device manufacturer's TRB in accordance with MIL-PRF-38535 and shall be made available to the acquiring or preparing activity upon request. The test circuit shall specify the inputs, outputs, biases, and power dissipation, as applicable, in accordance with the intent specified in test method 1005 of MIL-STD-883.
  - 4.4.3 Group D inspection. The group D inspection end-point electrical parameters shall be as specified in table II herein.
- 4.4.4 <u>Group E inspection</u>. Group E inspection is required only for parts intended to be marked as radiation hardness assured (see 3.5 herein). RHA levels for device classes M, Q and V shall be as specified in MIL-PRF-38535. End-point electrical parameters shall be as specified in table IIA herein.
- 4.4.4.1 <u>Total dose irradiation testing</u>. Total dose irradiation testing shall be performed in accordance with MIL-STD-883 method 1019 and as specified herein.
- 4.4.4.1.1 <u>Accelerated aging test</u>. Accelerated aging tests shall be performed on all devices requiring a RHA level greater than 5k rads(Si). The post-anneal end-point electrical parameter limits shall be as specified in table I herein and shall be the pre-irradiation end-point electrical parameter limit at +25°C ±5°C. Testing shall be performed at initial qualification and after any design or process changes which may affect the RHA response of the device.
- 4.4.4.2 <u>Dose rate induced latchup testing</u>. Dose rate induced latchup testing shall be performed in accordance with test method 1020 of MIL-STD-883 and as specified herein (see 1.4 herein). Tests shall be performed on devices, SEC, or approved test structures at technology qualification and after any design or process changes which may effect the RHA capability of the process.
- 4.4.4.3 <u>Dose rate upset testing</u>. Dose rate upset testing shall be performed in accordance with test method 1021 of MIL-STD-883 and herein (see 1.4 herein).
  - a. Transient dose rate upset testing shall be performed at initial qualification and after any design or process changes which may effect the RHA performance of the devices. Test 10 devices with 0 defects unless otherwise specified.
  - b. Transient dose rate upset testing for class Q and V devices shall be performed as specified by a TRB approved radiation hardness assurance plan and MIL-PRF-38535.
- 4.4.4.4 <u>Single event phenomena (SEP)</u>. SEP testing shall be required on class V devices (see 1.4 herein). SEP testing shall be performed on a technology process on the Standard Evaluation Circuit (SEC) or alternate SEP test vehicle as approved by the qualifying activity at initial qualification and after any design or process changes which may affect the upset or latchup characteristics. The recommended test conditions for SEP are as follows:
  - a. The ion beam angle of incidence shall be between normal to the die surface and 60° to the normal, inclusive (i.e. 0° ≤ angle ≤ 60°). No shadowing of the ion beam due to fixturing or package related effects is allowed.
  - b. The fluence shall be  $\geq 100$  errors or  $\geq 10^6$  ions/cm<sup>2</sup>.
  - c. The flux shall be between 10<sup>2</sup> and 10<sup>5</sup> ions/cm<sup>2</sup>/s. The cross-section shall be verified to be flux independent by measuring the cross-section at two flux rates which differ by at least an order of magnitude.
  - d. The particle range shall be  $\geq$  20 microns in silicon.
  - e. The test temperature shall be +25°C and the maximum rated operating temperature ±10°C.

STANDARD MICROCIRCUIT DRAWING	SIZE <b>A</b>		5962-96713
DEFENSE SUPPLY CENTER COLUMBUS		REVISION LEVEL	SHEET
COLUMBUS, OHIO 43216-5000		C	15

- f. Bias conditions shall be defined by the manufacturer for latchup measurements.
- g. Test four devices with zero failures.
- 4.5 Methods of inspection. Methods of inspection shall be as specified as follows:
- 4.5.1 <u>Voltage and current</u>. Unless otherwise specified, all voltages given are referenced to the microcircuit GND terminal. Currents given are conventional current and positive when flowing into the referenced terminal.

Table III. Irradiation test connections. 1/

Open	Ground	$V_{CC} = 5 V \pm 0.5 V$
5, 6, 8, 9	7	1, 2, 3, 4, 10, 11, 12, 13, 14

1/ Each pin except V<sub>CC</sub> and GND will have a series resistor of 47KΩ ±5%, for irradiation testing.

## 5. PACKAGING

5.1 <u>Packaging requirements</u>. The requirements for packaging shall be in accordance with MIL-PRF-38535 for device classes Q and V or MIL-PRF-38535, appendix A for device class M.

## 6. NOTES

- 6.1 <u>Intended use</u>. Microcircuits conforming to this drawing are intended for use for Government microcircuit applications (original equipment), design applications, and logistics purposes.
- 6.1.1 <u>Replaceability</u>. Microcircuits covered by this drawing will replace the same generic device covered by a contractor prepared specification or drawing.
  - 6.1.2 Substitutability. Device class Q devices will replace device class M devices.
- 6.2 <u>Configuration control of SMD's</u>. All proposed changes to existing SMD's will be coordinated with the users of record for the individual documents. This coordination will be accomplished in accordance with MIL-STD-973 using DD Form 1692, Engineering Change Proposal.
- 6.3 <u>Record of users</u>. Military and industrial users should inform Defense Supply Center Columbus when a system application requires configuration control and which SMD's are applicable to that system. DSCC will maintain a record of users and this list will be used for coordination and distribution of changes to the drawings. Users of drawings covering microelectronic devices (FSC 5962) should contact DSCC-VA, telephone (614) 692-0525.
- 6.4 <u>Comments</u>. Comments on this drawing should be directed to DSCC-VA, Columbus, Ohio 43216-5000, or telephone (614) 692-0674.
- 6.5 <u>Abbreviations, symbols, and definitions</u>. The abbreviations, symbols, and definitions used herein are defined in MIL-PRF-38535 and MIL-HDBK-1331.

GND	Ground zero voltage potential.
I <sub>CC</sub>	Quiescent supply current.
I <sub>IL</sub>	Input current low.
I <sub>IH</sub>	Input current high.
T <sub>C</sub>	Case temperature.
T <sub>A</sub>	Ambient temperature.
V <sub>CC</sub>	Positive supply voltage.
C <sub>IN</sub>	Input terminal-to-GND capacitance.
C <sub>OUT</sub>	Output terminal-to-GND capacitance.
C <sub>PD</sub>	Power dissipation capacitance.

STANDARD MICROCIRCUIT DRAWING	SIZE <b>A</b>		5962-96713
DEFENSE SUPPLY CENTER COLUMBUS		REVISION LEVEL	SHEET
COLUMBUS, OHIO 43216-5000		C	16

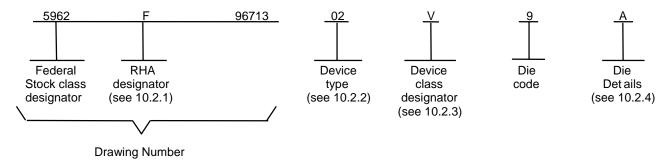
- 6.6 Sources of supply.
- 6.6.1 <u>Sources of supply for device classes Q and V</u>. Sources of supply for device classes Q and V are listed in QML-38535. The vendors listed in QML-38535 have submitted a certificate of compliance (see 3.6 herein) to DSCC-VA and have agreed to this drawing.
- 6.6.2 <u>Approved sources of supply for device class M.</u> Approved sources of supply for class M are listed in MIL-HDBK-103. The vendors listed in MIL-HDBK-103 have agreed to this drawing and a certificate of compliance (see 3.6 herein) has been submitted to and accepted by DSCC-VA.
- 6.7 <u>Additional information</u>. A copy of the following additional data shall be maintained and available from the device manufacturer:
  - a. RHA upset levels.
  - b. Test conditions (SEP).
  - c. Number of upsets (SEP).
  - d. Number of transients (SEP).
  - e. Occurrence of latchup (SEP).

STANDARD
MICROCIRCUIT DRAWING

SIZE <b>A</b>		5962-96	5713
	REVISION LEVEL C	SHEET	17

## 10. SCOPE

- 10.1 <u>Scope</u>. This appendix establishes minimum requirements for microcircuit die to be supplied under the Qualified Manufacturers List (QML) Program. QML microcircuit die meeting the requirements of MIL-PRF-38535 and the manufacturers approved QM plan for use in monolithic microcircuits, multichip modules (MCMs), hybrids, electronic modules, or devices using chip and wire designs in accordance with MIL-PRF-38534 are specified herein. Two product assurance classes consisting of military high reliability (device class Q) and space application (device Class V) are reflected in the Part or Identification Number (PIN). When available a choice of Radiation Hardiness Assurance (RHA) levels are reflected in the PIN.
  - 10.2 PIN. The PIN shall be as shown in the following example:



- 10.2.1 RHA designator. Device classes Q and V RHA identified die shall meet the MIL-PRF-38535 specified RHA levels. A dash (-) indicates a non-RHA die.
  - 10.2.2 <u>Device type(s)</u>. The device type(s) shall identify the circuit function as follows:

Device type	Generic number	Circuit function
02	ACTS74-02	Radiation hardened, SOS, advanced CMOS, dual D flip-flop with set and reset, TTL compatible inputs.

# 10.2.3 <u>Device class designator</u>.

Device class	Device requirements documentation
Q or V	Certification and qualification to the die requirements of MIL-PRF-38535.

STANDARD MICROCIRCUIT DRAWING	SIZE <b>A</b>		5962-96713
DEFENSE SUPPLY CENTER COLUMBUS COLUMBUS, OHIO 43216-5000		REVISION LEVEL C	SHEET 18

10.2.4 <u>Die Details</u>. The die details designation shall be a unique letter which designates the die's physical dimensions, bonding pad location(s) and related electrical function(s), interface materials, and other assembly related information, for each product and variant supplied to this appendix.

10.2.4.1 Die Physical dimensions.

Die Types Figure number

02 A-1

10.2.4.2 Die Bonding pad locations and Electrical functions.

Die Types Figure number

02 A-1

10.2.4.3 Interface Materials.

Die Types Figure number

02 A-1

10.2.4.4 Assembly related information.

Die Types Figure number

02 A-1

- 10.3 Absolute maximum ratings. See paragraph 1.3 within the body of this drawing for details.
- 10.4 Recommended operating conditions. See paragraph 1.4 within the body of this drawing for details.
- 20. APPLICABLE DOCUMENTS
- 20.1 <u>Government specifications, standards, bulletin, and handbooks</u>. Unless otherwise specified, the following specifications, standards, bulletin, and handbook of the issue listed in that issue of the Department of Defense Index of Specifications and Standards specified in the solicitation, form a part of this drawing to the extent specified herein.

STANDARD
MICROCIRCUIT DRAWING

SIZE <b>A</b>		5962-	96713
	REVISION LEVEL C	SHEET	19

#### **SPECIFICATION**

## DEPARTMENT OF DEFENSE

MIL-PRF-38535 - Integrated Circuits, Manufacturing, General Specification for.

#### **STANDARDS**

## DEPARTMENT OF DEFENSE

MIL-STD-883 - Test Method Standard Microcircuits.

#### **HANDBOOK**

#### DEPARTMENT OF DEFENSE

MIL-HDBK-103 - List of Standard Microcircuit Drawings.

(Copies of the specification, standards, bulletin, and handbook required by manufacturers in connection with specific acquisition functions should be obtained from the contracting activity or as directed by the contracting activity).

20.2 <u>Order of precedence</u>. In the event of a conflict between the text of this drawing and the references cited herein, the text of this drawing shall take precedence.

## 30. REQUIREMENTS

- 30.1 <u>Item Requirements</u>. The individual item requirements for device classes Q and V shall be in accordance with MIL-PRF-38535 and as specified herein or as modified in the device manufacturer's Quality Management (QM) plan. The modification in the QM plan shall not effect the form, fit or function as described herein.
- 30.2 <u>Design, construction and physical dimensions</u>. The design, construction and physical dimensions shall be as specified in MIL-PRF-38535 and the manufacturer's QM plan, for device classes Q and V and herein.
  - 30.2.1 Die Physical dimensions. The die physical dimensions shall be as specified in 10.2.4.1 and on figure A-1.
- 30.2.2 <u>Die bonding pad locations and electrical functions</u>. The die bonding pad locations and electrical functions shall be as specified in 10.2.4.2 and on figure A-1.
  - 30.2.3 Interface materials. The interface materials for the die shall be as specified in 10.2.4.3 and on figure A-1.
  - 30.2.4 Assembly related information. The assembly related information shall be as specified in 10.2.4.4 and figure A-1.
  - 30.2.5 Truth table. The truth table shall be as defined within paragraph 3.2.3 of the body of this document.
- 30.2.6 <u>Radiation exposure circuit</u>. The radiation exposure circuit shall be as defined within paragraph 3.2.6 of the body of this document.

STANDARD	
MICROCIRCUIT DRAWING	

SIZE <b>A</b>		5962-96713
	REVISION LEVEL C	SHEET 20

- 30.3 <u>Electrical performance characteristics and post-irradiation parameter limits</u>. Unless otherwise specified herein, the electrical performance characteristics and post-irradiation parameter limits are as specified in table I of the body of this document.
- 30.4 <u>Electrical test requirements</u>. The wafer probe test requirements shall include functional and parametric testing sufficient to make the packaged die capable of meeting the electrical performance requirements in table I.
- 30.5 <u>Marking</u>. As a minimum, each unique lot of die, loaded in single or multiple stack of carriers, for shipment to a customer, shall be identified with the wafer lot number, the certification mark, the manufacturer's identification and the PIN listed in 10.2 herein. The certification mark shall be a "QML" or "Q" as required by MIL-PRF-38535.
- 30.6 <u>Certification of compliance</u>. For device classes Q and V, a certificate of compliance shall be required from a QML-38535 listed manufacturer in order to supply to the requirements of this drawing (see 60.4 herein). The certificate of compliance submitted to DSCC-VA prior to listing as an approved source of supply for this appendix shall affirm that the manufacturer's product meets, for device classes Q and V, the requirements of MIL-PRF-38535 and the requirements herein.
- 30.7 <u>Certificate of conformance</u>. A certificate of conformance as required for device classes Q and V in MIL-PRF-38535 shall be provided with each lot of microcircuit die delivered to this drawing.
  - 40. QUALITY ASSURANCE PROVISIONS
- 40.1 <u>Sampling and inspection</u>. For device classes Q and V, die sampling and inspection procedures shall be in accordance with MIL-PRF-38535 or as modified in the device manufacturer's Quality Management (QM) plan. The modifications in the QM plan shall not effect the form, fit or function as described herein.
- 40.2 <u>Screening</u>. For device classes Q and V, screening shall be in accordance with MIL-PRF-38535, and as defined in the manufacturer's QM plan. As a minimum it shall consist of:
  - a) Wafer Lot acceptance for Class V product using the criteria defined within MIL-STD-883 TM 5007.
  - b) 100% wafer probe (see paragraph 30.4).
  - c) 100% internal visual inspection to the applicable class Q or V criteria defined within MIL-STD-883 TM2010 or the alternate procedures allowed within MIL-STD-883 TM5004.

STANDARD		
MICROCIRCUIT DRAWING		

SIZE <b>A</b>		5962-96713
	REVISION LEVEL C	SHEET 21

## 40.3 Conformance inspection.

40.3.1 <u>Group E inspection</u>. Group E inspection is required only for parts intended to be identified as radiation assured (see 30.5 herein). RHA levels for device classes Q and V shall be as specified in MIL-PRF-38535. End point electrical testing of packaged die shall be as specified in table IIA herein. Group E tests and conditions are as specified within paragraphs 4.4.4.1, 4.4.4.2, 4.4.4.3, and 4.4.4.4.

#### 50. DIE CARRIER

50.1 <u>Die carrier requirements</u>. The requirements for the die carrier shall be in accordance with the manufacturer's QM plan or as specified in the purchase order by the acquiring activity. The die carrier shall provide adequate physical, mechanical and electrostatic protection.

#### 60. NOTES

- 60.1 <u>Intended use</u>. Microcircuit die conforming to this drawing are intended for use in microcircuits built in accordance with MIL-PRF-38535 or MIL-PRF-38534 for government microcircuit applications (original equipment), design applications and logistics purposes.
- 60.2 <u>Comments</u>. Comments on this appendix should be directed to DSCC-VA, Columbus, Ohio, 43216-5000 or telephone (614)-692-0674.
- 60.3 <u>Abbreviations, symbols and definitions</u>. The abbreviations, symbols, and definitions used herein are defined with MIL-PRF-38535 and MIL-HDBK-1331.
- 60.4 <u>Sources of Supply for device classes Q and V</u>. Sources of supply for device classes Q and V are listed in QML-38535. The vendors listed within QML-38535 have submitted a certificate of compliance (see 30.6 herein) to DSCC-VA and have agreed to this drawing.

STANDARD		
MICROCIRCUIT DRAWING		

SIZE <b>A</b>		5962-96713
	REVISION LEVEL C	SHEET 22

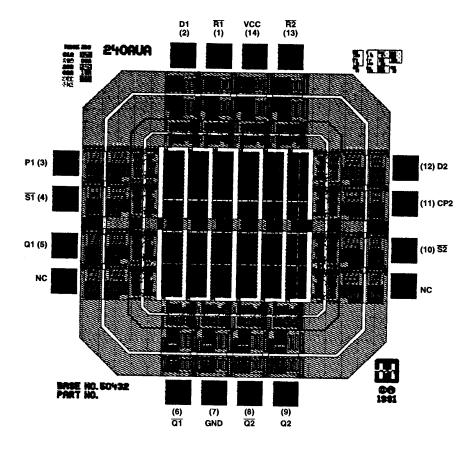
# FIGURE A-1

# o DIE PHYSICAL DIMENSIONS

Die Size: 2240 x 2240 microns. Die Thickness: 21 +/- 2 mils.

## • DIE BONDING PAD LOCATIONS AND ELECTRICAL FUNCTIONS

The following metallization diagram supplies the locations and electrical functions of the bonding pads. The internal metallization layout and alphanumeric information contained within this diagram may or may not represent the actual circuit defined by this SMD.



NOTE: Pad numbers reflect terminal numbers when placed in Case Outlines C, X (see Figure 1).

STANDARD MICROCIRCUIT DRAWING	SIZE <b>A</b>		5962-96713
DEFENSE SUPPLY CENTER COLUMBUS COLUMBUS, OHIO 43216-5000		REVISION LEVEL C	SHEET 23

# o INTERFACE MATERIALS

Device 02

Metal 1: AISi 7.0kA +/- 1.0kA Metal 2 (Top): AISi 10.0kA +/- 1.0kA

Backside Metallization None

Device 02 Glassivation

Type: PSG

Thickness 13.0kA +/- 1.5kA

Substrate: Silicon on Sapphire (SOS)

o ASSEMBLY RELATED INFORMATION

Substrate Potential: Insulator

Special assembly

instructions: Bond pad #14 (VCC) first.

STANDARD MICROCIRCUIT DRAWING	SIZE <b>A</b>		
DEFENSE SUPPLY CENTER COLUMBUS COLUMBUS, OHIO 43216-5000		REVISION LEVEL C	

5962-96713

24

SHEET

## STANDARD MICROCIRCUIT DRAWING BULLETIN

DATE: 00-06-26

Approved sources of supply for SMD 5962-96713 are listed below for immediate acquisition information only and shall be added to MIL-HDBK-103 and QML-38535 during the next revision. MIL-HDBK-103 and QML-38535 will be revised to include the addition or deletion of sources. The vendors listed below have agreed to this drawing and a certificate of compliance has been submitted to and accepted by DSCC-VA. This bulletin is superseded by the next dated revision of MIL-HDBK-103 and QML-38535.

Standard microcircuit drawing PIN <u>1</u> /	Vendor CAGE number	Vendor similar PIN <u>2</u> /
5962F9671301VCC	34371	ACTS74DMSR
5962F9671301VXC	34371	ACTS74KMSR
5962F9671302VCC	34371	ACTS74DMSR-02
5962F9671302VXC	34371	ACTS74KMSR-02
5962F9671302V9A	34371	ACTS74HMSR-02

- 1/ The lead finish shown for each PIN representing a hermetic package is the most readily available from the manufacturer listed for that part. If the desired lead finish is not listed contact the vendor to determine its availability.
- 2/ Caution. Do not use this number for item acquisition. Items acquired to this number may not satisfy the performance requirements of this drawing.

Vendor CAGE <u>number</u> Vendor name and address

34371

Intersil Corporation PO Box 883

Melbourne, FL 32902-0883

The information contained herein is disseminated for convenience only and the Government assumes no liability whatsoever for any inaccuracies in the information bulletin.